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	APPLICANT	NAITO et al.	
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REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
SSS	5,679,153 (Discussed on page 2 of the spec.)	Oct. 21, 1997	Dmitriev et al.		
SSS	6,153,165 (Corresponding to JP-A-10-324600 which is discussed on page 2 of the spec.)	Nov. 28, 2000	Tanino et al.		
SSS	6,214,108 (Corresponding to JP-A-2000-44398 which is discussed on page 2 of the spec.)	Apr. 10, 2001	Okamoto et al.		
SSS	6,153,166	Nov. 28, 2000	Tanino		
SSS	6,203,772	Mar. 20, 2001	Tanino et al.		

FOREIGN PATENT DOCUMENTS

								TRANSLATION	
		DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB CLASS	YES	NO
SSS		JP-A-2000-34198 *	2/2/00	JAPAN				X	

* Full English text of the JP Document will be available in machine-translated form from JP (Japanese Patent Office) English language web site at <http://www1.ipdl.jpo.go.jp/PA1/cgi-bin/PA1INDEX>.

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

SSS	Kamata et al., "Migration of shifting in epitaxial growth of thick 4H-SiC," <u>Abstract of the Lecture of 47th Japan Society of Applied Physics Related Association</u> , separate Volume 1, p.407, No. 29p-YF-6, March 2000. (Discussed on page 2 of the spec.)
EXAMINER	DATE CONSIDERED
<i>Stephen Stern</i>	6/23/03